Docket No. SH-0067PCTUS Serial No. 10/593,268 RYU.030

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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MAY 14 2009 W

In re patent application of

Makoto YOSHIDA, et al.

Serial No.:

10/593,268

**Group Art Unit:** 

1791

Filed:

September 18, 2006

Examiner:

Unknown

For:

SINTERING METHOD AND SINTERING APPARATUS OF

POROUS GLASS BASE MATERIAL

Honorable Commissioner of Patents Alexandria, Virginia 22313-1450

## INFORMATION DISCLOSURE STATEMENT

Sir:

Under the provisions of 37 CFR §1.97 through §1.98 and pursuant to Applicants' duty of disclosure under 37 CFR §1.56, Applicants respectfully bring the following document cited in the Chinese Office Action in a counterpart foreign application and listed on the attached form PTO-1449, to the attention of the Examiner in charge of the above-identified application.

I hereby certify that each item of information contained in this Information Disclosure Statement was the first citation of that item by a foreign patent office in a counterpart foreign application, which occurred not more than three months prior to the filing of this statement.

It is respectfully requested that the listed reference be considered by the Examiner and formally made of record in this application.

Please charge any deficiencies in fees and credit any overpayment of fees to Attorney's Deposit Account No. 50-0481.

Date:

MCGINN INTELLECTUAL PROPERTY

LAW GROUP, PLLC

8321 Old Courthouse Road, Suite 200 Vienna, Virginia 22182-3817

(703) 761-4100, Customer No. 21254

Respectfully submitted,

Sean M. W. Ginn, Esq. Registration No. 34,386